

REQUEST FOR CONTINUED EXAMINATION

PATENT APPLICATION
Docket No. 5484-048
Client No. PX828-US/SSD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup Shim and Young-Ho Kim

Serial No. 09/305,240 Examiner: Nadav, Ori

Filed: May 4, 1999 Art Unit: 2811

For: OPEN DRAIN INPUT/OUTPUT STRUCTURE AND
MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR
DEVICE

Confirmation No. 1838

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


AMENDMENT

Responsive to the Final Office Action mailed on 7 October 2003 and the Advisory
Action mailed on 20 January 2004, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of
this paper.

Remarks/Arguments begin on page 9 of this paper.

I hereby certify that this correspondence is being
deposited with the United States Postal Service as
first class mail in an envelope addressed to: Mail
Stop RCE; Commissioner for Patents, P.O. Box
1450, Alexandria, VA 22313-1450
Date: February 19, 2004.


Adrienne Chocholak